

INSTRUCTURED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Sun-Lee Hwang et al. : Group Art Unit: 2812

Application No. 10/805,225 : Examiner: TBA

Filed: March 22, 2004

For: METHOD OF ALIGNING A SEMICONDUCTOR SUBSTRATE WITH A

SEMICONDUCTOR ALIGNMENT APPARATUS

STATUS CHECK

U.S. Patent and Trademark Office Customer Service Window Randolph Building 401 Dulany Street Alexandria VA 22314

Sir:

Kindly immediately advise the undersigned of the status of the above-identified application.

Respectfully submitted,

Volentine Francos & Whitt, PLLC

Adam C. Volentine Registration No. 33,289

One Freedom Square 11951 Freedom Drive, Suite 1260 Reston VA 20190 Tel. (703) 715-0870

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